

<b>Notice of References Cited</b>	Application/Control No. 10/593,587		Applicant(s)/Patent Under Reexamination ALVAREZ AREVALO ET AL.	
	Examiner Andrew C. Lee		Art Unit 2476	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,792,047	09-2004	Bixby et al.	375/240.26
*	B	US-5,598,352	01-1997	Rosenau et al.	715/203
*	C	US-5,923,655	07-1999	Veschi et al.	370/394
*	D	US-6,195,368	02-2001	Gratacap, Regis	370/535
*	E	US-2002/0031120	03-2002	Rakib, Selim Shlomo	370/386
*	F	US-6,771,703	08-2004	Oguz et al.	375/240.03
*	G	US-6,678,332	01-2004	Gardere et al.	375/240.26
*	H	US-7,096,481	08-2006	Forecast et al.	725/32
*	I	US-7,016,970	03-2006	Harumoto et al.	709/233
*	J	US-2005/0071876	03-2006	van Beek, Petrus J. L.	725/062
*	K	US-5,949,410	09-1999	Fung, Hei Tao	715/203
*	L	US-6,453,112	09-2002	Imahashi et al.	386/46
*	M	US-6,438,317	08-2002	Imahashi et al.	386/109

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	I					

#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.